

Attv. Dkt. No. 039153-0306 (F0793)

HE UNITED STATES PATENT AND TRADEMARK OFFICE

Applicant: Piao et al.

Title:

CONFIGURABLE RETICLE FOR

LITHOGRAPHY AND A METHOD OF MAKING INTEGRATED CIRCUITS USING SUCH A

RETICLE

Appl. No.: 09/775,059

Filing Date: 02/01/2001

Examiner: Unknown

2811 Art Unit:

with the United States Postal Service with sufficient nostano as First Class Mail in an envalone addressed to: Patents, Washington, D.C. 20231, on

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TRANSMITTAL OF FORMAL DRAWINGS

Commissioner for Patents

Washington, D.C. 20231

ATTENTION: DRAWING REVIEW BRANCH

Sir:

Transmitted herewith are the formal drawings (8 sheets, Figures 1-8) for the above-identified application. The Official Draftsperson is respectfully requested to approve these drawings for entry into the application.

Respectfully submitteRECEVFD 0CT 15 2001

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